

## SEARCHED

Class	Sub.	Date	Exmr.
438	50-52	5/22/01	A.M.
updated		3/21/02	A.M.
updated		8/12/03	A.M.
438	706	1	1

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## INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

Microelectromechanical MEMS, MICS.	Date	Exmr.
	5/21/01	A.M.
EAS (all). + Inventors - + Micromachine + Trench + ZCB	8/12/03	A.M.